

Notice of References Cited	Application/Control No. 09/295,607	Applicant(s)/Patent Under Reexamination YAMAZAKI ET AL.	
	Examiner Steven Loke	Art Unit 2811	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-5,132,754	07-1992	Serikawa et al.	257/57
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	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"Aluminum Nitride - An Alternative Ceramic Substrate for High Power Applications in Microcircuits" by Werdecker et al., IEEE Transactions on Components, Hybrids, and Manufacturing Technology", Vol. Chmt-7, No. 4, December 1984, pages 399-404.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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